

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:
Nguyen, et al.

Serial No.: 09/912,103

Confirmation No.: 4476

Filed: July 23, 2001

For: Selective Etching of
Organosilicate Films Over
Silicon Oxide Stop Etch
LayersCommissioner for Patents
Washington, D.C. 20231

Dear Sir:

Group Art Unit: 2823

Examiner: Khiem D. Nguyen

CERTIFICATE OF MAILING
37 CFR 1.8

I hereby certify that this correspondence is being deposited on April 14, 2003 with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, Washington, D.C. 20231.

4/14/03 Khiem D. Nguyen
Date Signature

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

The Applicants, and the Attorney who signs below on the basis of the information supplied by the inventor and the information in his file, submit herewith patents, publications, or other information of which they are aware, which may be material to the examination of this application and in respect of which there may be a duty to disclose in accordance with 37 CFR § 1.56.

While the information submitted in this Supplemental Information Disclosure Statement may be material pursuant to 37 CFR § 1.56, it is not intended to constitute an admission that any patent, publication, or other information referred to therein is prior art for this invention unless specifically designated as such.

In accordance with 37 CFR § 1.97, this Supplemental Information Disclosure Statement is not to be construed as a representation that a search has been made or that no other possibly material information as defined under 37 CFR § 1.56(a) exists.

The patents and/or publications submitted herewith are set forth on the attached Form PTO-1449.

Although Applied does not believe a fee is due under 37 CFR § 1.17(p) pursuant to § 1.97, the Commissioner is hereby authorized to charge the fee of \$180.00, and any other fee necessary to make this submission timely, to the Deposit Account No. 20-0782/AMAT/5619/KMT.

Respectfully submitted,



Keith M. Tackett
Registration No. 32,008
MOSER, PATTERSON & SHERIDAN, L.L.P.
3040 Post Oak Blvd., Suite 1500
Houston, TX 77056
Telephone: (713) 623-4844
Facsimile: (713) 623-4846
Attorney for Applicant(s)